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033082M336

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuo KOBAYASHI, et al.

U.S. Serial No.: 10/585,994

Group Art Unit: To Be Assigned

Filed: : July 13, 2006

Examiner: To Be Assigned

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
AND FILM DEPOSITION SYSTEM

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of JP10-144667A, which is cited and discussed on pages 1 and 2 of Applicants' specification.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
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October 11, 2006



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M336	SERIAL NO. 10/585,994
	APPLICANT: Yasuo KOBAYASHI, et al.	
	FILING DATE July 13, 2006	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AH	10-144667	5/29/98	Japan			Abstract	
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.